



IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

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Patent Application

Inventors: R.T. Aiken

J. Huang

Case: 5-11

Serial No.: 09/672512

Group Art Unit: 2686

Filed: 9/28/00

Examiner: Roberts P. Culbert

Title: Method of Etching Ferroelectric Material

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Technology Center 2600

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SIR:

REQUEST FOR RECONSIDERATION

In response to the Office Action dated September 30, 2003, please amend the above-identified application as follows:

- Remarks begin on page 2 of this paper

Date of Deposit	January 30, 2004
I hereby certify that this correspondence is being deposited with the United States Postal Service in a First Class Mail envelope on the date indicated above and is addressed to:	
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